



DOCKET: CU-2757

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2814
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application: Woo Seock CHEONG

Serial No.: 10/034,228

GRP ART UNIT: 2814

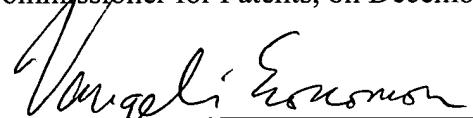
Filed: December 28, 2001

Ex.: Pham, Long

For: METHOD OF MANUFACTURING A
SEMICONDUCTOR DEVICE

Certification under 37 C.F.R. §1.8(a)

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with The United States Postal Service with sufficient postage as first class mail in an envelope addressed to Commissioner for Patents, on December 12, 2003.



Vangelis Economou - Reg. No. 32,341

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE TO RESTRICTION REQUIREMENT

Sir:

In response to the restriction requirement in the Office Action dated November 12, 2003, Applicant provisionally elects Group I, Claims 1-5 and 10-12, 14, 15, 18, 25 and 27-40, drawn to a method of marking a semiconductor device, first embodiment, relating to Figs 5-7. Applicant's reserve the opportunity to file a divisional application on the Group II and III claims in the future.

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